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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Notice of Allowance Mailed: September 8, 2004
Issue Fee Paid: December 3, 2004

Application No.: 09/871,600
Filing Date: May 31, 2001
Applicant: Akira ARAI
Group Art Unit: 1742
Examiner: John P. Sheehan
Title: MAGNETIC POWDER, MANUFACTURING METHOD
OF MAGNETIC POWDER AND BONDED MAGNETS
Attorney Docket: 9319A-000222

Director of the United States Patent and Trademark Office
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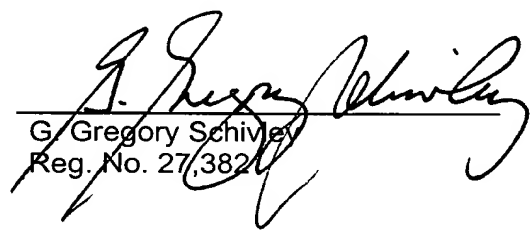
MAKE OF RECORD LETTER

Sir:

Please make the information set forth on the enclosed Form 1449 of record in this file.
The listed documents were cited in a search report for a corresponding European patent application. However, Applicant makes no admission that the disclosures in these documents affect the presumption of validity for the claims in this issued patent.

Respectfully submitted,

Dated: May 6, 2005

By: 
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INFORMATION DISCLOSURE CITATION**

(Use several sheets if necessary)

Sheet 1 of 1

ATTORNEY DOCKET NO.

SERIAL No.

9319A-000222

09/871,600

APPLICANT

Akira ARAI

FILING DATE

GROUP

May 31, 2001

1742

U.S. PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.						

FOREIGN PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation * Yes	No
1.		0 823 713	2/11/1998	EPO		N/A	
2.		0 302 395	7/28/1988	EPO		N/A	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

Ref. Desig.	Examiner's Initials	
1.		Communication from European Patent Office re: counterpart application.

*One or more of the English translation documents submitted herewith may be Abstracts only or partial machine created translations from the Japanese Patent Office. As such, the submitter does not necessarily vouch for their accuracy. Additional information may be obtained from the Japanese Patent Office web site at www.jpo.go.jp

Examiner:

Date Considered:

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